

Method and device for coating substrates

Abstract

The present invention relates to a method for coating a substrate (6) with a film layer, characterised in that the device comprises application means (1) for applying a thermoplastic film layer material (4) and distribution means for distributing the film layer material (4) on the substrate (6) for the formation of the film layer.

Furthermore, the present invention relates to a corresponding device.

See in this regard figure 1.